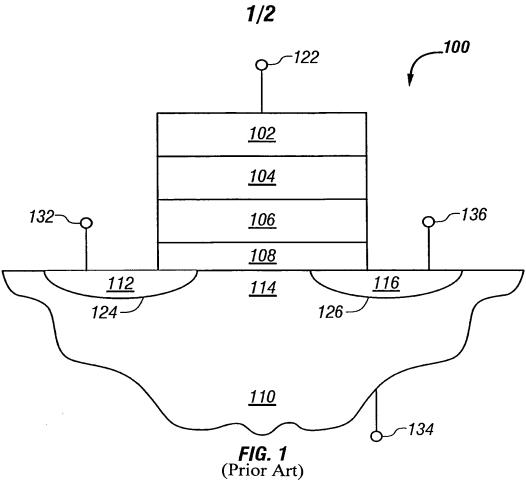
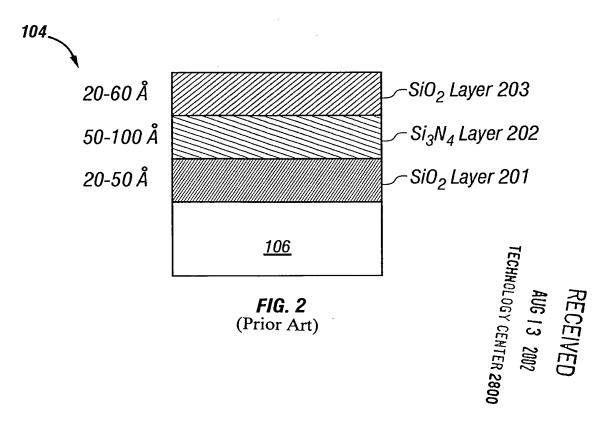


Process For Peating ONO Dielectric Film Of A Floating Late Memory Cell Appln. : 09/927,134 Inventors: Berran et al.







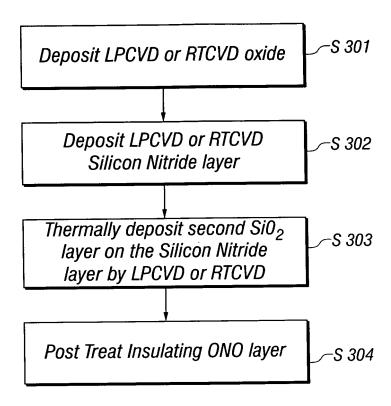


FIG. 3